ATTORNEY DOCKET NO.: AGX-14-CPA

Examiner: NGUYEN, KIET

Art Unit: 2881

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**ORIGINALLY FILED** 

In re Application of Gat et al.

Serial No.: 09/226,396

Filed: January 6, 1999

For: HEATING DEVICE FOR HEATING SEMICONDUCTOR WAFERS IN THERMAL PROCESSING CHAMBERS

Commissioner for Patents Box Amendment Washington, D.C. 20231 RECEIVED

MAY 08 2002

**TECH CENTER 2800** 

## **AMENDMENT**

Sir:

In response to the Office Action of November 20, 2001, please amend the above-captioned application as set forth below and consider the remarks that follow.

## **IN THE DRAWINGS**

Applicants propose amending Fig. 1 as set forth on the Request for Approval of Drawing Changes accompanying this Amendment.

## IN THE CLAIMS

Please amend claims 48 and 55 as follows, all without prejudice or disclaimer. A marked-up copy of the claims as amended is attached for the Examiner's convenience.

48. (Amended) An apparatus as defined in claim 47, wherein said controller is configured to control the amount of light energy being emitted by said at least one tuning device independently of said light energy sources.

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